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2 November 2009

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### Confirmation of Office Interview

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450  
Director Frederick R Schmidt  
Director's Facsimile No.: (571)273-5150  
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Re.: U.S. Patent Application for:  
*ELECTROMECHANICAL CYLINDER PLUG*  
Serial No. 10/630,759  
Richard G. Hyatt, Jr.  
Attorney's Docket No. P56934

Sir:

This is to confirm the Office Interview scheduled for 10<sup>th</sup> of November 1:30 pm to be held between:

1. Director Frederick R Schmidt, Director TC 3600;
2. Examiner Suzanne Dino Barrett, Primary Examiner, Art Unit 3673;
3. Robert E Bushnell, Applicant's under signed Attorney.

The itinerary includes explanation of the repeated in prolong suspension of the application, the justification for the suspension of the application, the benefit of attained by the applicant during each of the suspensions, and the technical questions concomitant with the art rejections given in paper No. 20090331 issued on the 16<sup>th</sup> of April 2009.

Respectfully submitted,

/Robert E Bushnell/  
Robert E. Bushnell

REB/aj